



REPLY UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 2800

Attorney Docket No. 002013.P135

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Seong Hyun Kim, et al.

Filed: November 25, 2003

Serial No: 10/722,818

For: **VERTICAL STRUCTURE THIN  
FILM TRANSISTOR**

Examiner: Tuan N. Quach

Art Unit: 2814

*Enter  
w/ACE  
dated  
9-28-05*

*C. Stanley  
10-6-05*

Mail Stop AF  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Dear Commissioner:

In connection with the Final Office Action mailed May 25, 2005, regarding the above-referenced application, Applicant respectfully requests consideration of the following amendments and remarks below.